

<b>Search Notes</b> 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/084,105	PHELPS, ANDREW
	Examiner Gabriel L. Chu	Art Unit 2114

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
714	53	4/14	JL
	768	1	(
	805	4/14	JLC